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XA-10036
PATENT APPLICATION

RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE - EXAMINING GROUP 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

First Named Inventor: TAMAKI, YOICHI. Art Unit: 2814
Application No.: 10/773,658 Examiner: L. Pham
Filed: February 9, 2004 Conf. No.: 7635
For: SEMICONDUCTOR DEVICE

* * *

RESPONSE AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is submitted in response to the Office
Action dated March 21, 2007, in the above-identified patent
application.

Remarks/Arguments begin on page 2 of this paper.